



Pulse-to-pulse Beam Modulation for KEKB and PF Injections and Energy Management at KEK 8GeV Linac

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KEKB

Electron Accelerator Complex

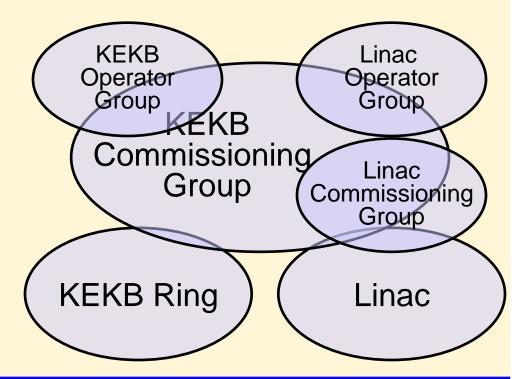
Linac clients KEKB Advanced Ring for pulse X-ravs) 8-GeV e- 1nC x2 3.5-GeV e+ 1nC x2 (with 10nC primary e-) PF 2.5-GeV e- 0.1nC (Photon Factory) PF-AR 3-GeV e– 0.2nC At first simultaneous top-up injections to three rings at KEKB and PF Switching beams at 50Hz For stable operation and higher quality exp. results

INAC



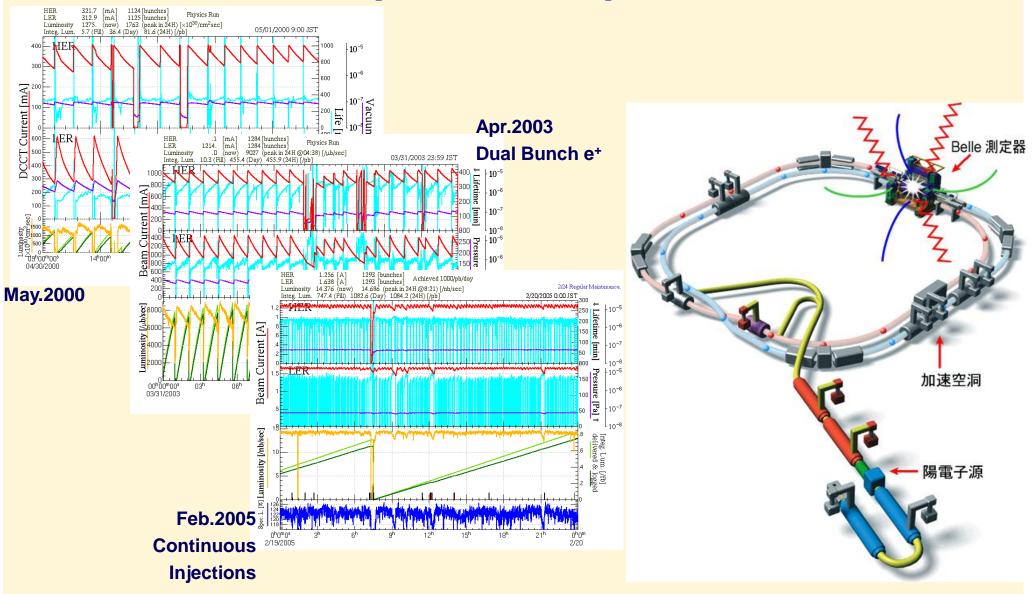
Operation

- Operation groups at KEKB and linac
 - Overlapped groups
 - Many attend commissioning group from eq. groups
 - Daily KCG meeting
 - Weekly LCG meeting



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KEKB Operation Improvement





Fast beam switching or Simultaneous Injection

- Luminosity degradation on beam studies at PF and PF/AR
- Future SuperKEKB injections with shorter lifetime
- Sensitive luminosity tuning with Crab cavities
- PF top-up injection for higher quality experiments
 - **CERN/PS** switches beams every 1.2s (PPM)
 - SLAC/SLC switched beams at 180 Hz
 - KEK Linac had switched beams 360 times a day in 2008 (just before simultaneous injection)
 - 10~120seconds per switching



Requirements

- Maximum beam rate of 50Hz x 2bunches should be kept
- Most pulsed power supplies were designed to operate at constant rate (a restriction)
- Most linac magnets were not pulsed (except positron focusing coil)
 - Thus, it took much time for mag-field standardization

Approx. 1000 devices in linac

*600 active devices (gun, RF, magnets, etc), 100 passive devices (BPM, WS, etc), and static devices

20ms beam switching became the solution



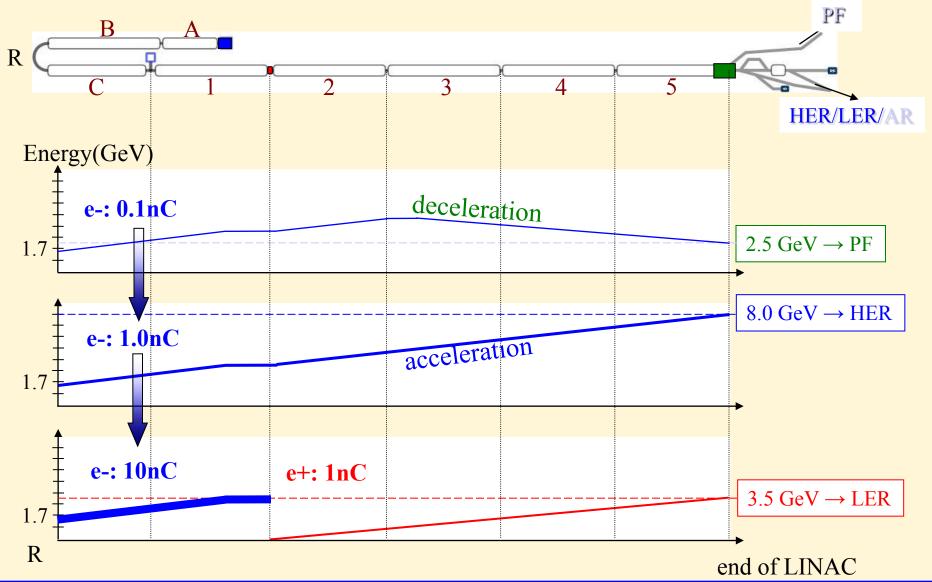
Hardware and Operation Improvements

- Separate BT for PF (2005)
- Pulsed bending magnet for PF (2007)
- PF beam from common gun (A1) (2007)
- Beam charge safety interlock (2007)
- Event-based fast control system (2008)
- Pulsed steering magnets (2008)
- Electron bypass hole at positron target (2008)
- Interface between ring-linac RF (2008)
- Multi-energy linac optics (2008)
- Simultaneous injections (Apr.2009)

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Linac Energy Profile



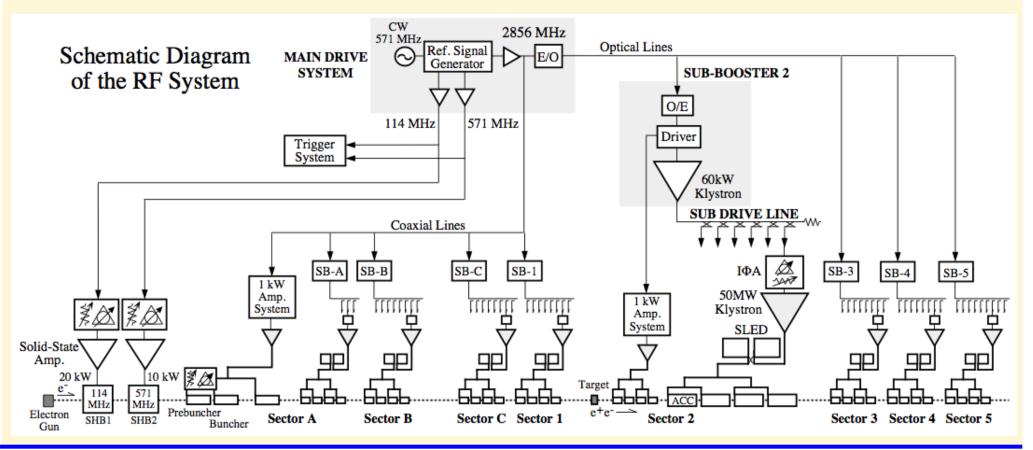
Simultaneous Injection and Energy Management

Kazuro Furukawa, KEK, Apr.2010. 8





Linac Energy Management





Power Management

- Power management at each power source
 - In the second second
 - In order to maximize the power
 - But not to increase the trip rate
 - ズ Interlock at a reflection level VSWR of 1.4
 - **If a trip rate is higher, the voltage is lowered**
 - Surveyed statistically every week

Some sources will be stand-by state

- As backups, if the energy is enough
 - KEKB e+ has several stand-by, KEKB e- has typically one

Energy conversion

Energy gain = constant x sqrt(power)



Cavity and Klystron Database

Updated on replacements of klystrons and cavities

Converted into control database

sector	unit	No	新/旧	typ	d(WG)	α	М	Es-Power	c2	c1	c0	Es	Power	Gain	Gain	Eave	stand	Total
					m			データ更新				kV	MW	MeV	MeV	MV/m	by	MeV
A	1	0	旧	-	-	_	1.00	04.08.30	-0.04728	6.58617	-138.81662	40.0	49.0	19.0	19	_	1	19
		1	新	Α	14.33	0.94400	1.00	04.08.30	-0.04728	6.58617	-138.81662	40.0	49.0	24.0	48	12.7		43
		2	新	Α	14.33	0.94400		*	п	"	n		п	24.0	*	12.7		67
	8	1	 H	D	13.28	0.93868	1.85	98.10.01	0.00000	1.93650	-38,76900	41.5	41.6	43.5	171	23.0	1	3004
	Ŭ	2	IH IH	D	13.35		"	*	0.00000	"	"	"	"	43.5	*	23.0		3047
		3		D		0.93868		-	0.00000					43.5	*	23.0		3091
		4		A		0.93834		-	0.00000					40.8		21.6		3131
1	1	1		-E	13.28	0.93868	1.85	_	0.00000	2.07020	-46,72400	43.0	42.3	44.8	179	23.7	- 1	3176
	•	2		E			1.00	*	0.00000	2.07020	-40.72400		42.0	44.8	*	23.7		3221
		3		E		0.93868		*	0.00000					44.8	*	23.7		3266
		4		E	13.35	0.93834		*	0.00000					44.8	*	23.7		3310
		4	IH IU		13.28	0.93868	1.85	03.09.16	0.00000	2.47830	-65.41700	41.5	37.4	40.4	162	23.7	-	3351
	2	-	IH	C			1.00	03.09.10	-	2.47030	-05.41700	41.5	37.4		102			
		2	Ш	C	13.35	0.93834			0.00000					40.4	π	21.4		3391
		3	IH	C	13.28	0.93868			0.00000					40.4	π	21.4		3432
		4	Ш	С		0.93834			0.00000					40.4		21.4		3472
	3	1	IH	D	13.28	0.93868	1.85	98.11.15	0.00000	2.32860	-55.54400	42.5	43.4	44.4	178	23.5	1	3516
		2	IH	D		0.93834		-	0.00000					44.4	*	23.5		3561
		3	IH	D	13.28	0.93868		•	0.00000	"				44.4	*	23.5		3605
		4	IH	D		0.93834		*	0.00000	"	"			44.4	*	23.5		3650
	4	1	Ш	С	13.28	0.93868	1.85	06.08.30	-0.12241	12.00654	-248.55271	43.5	42.1	42.8	171	22.7	1	3693
		2	IH	С	13.35	0.93834		*	0.00000	"	"			42.8	*	22.7		3735
		3	IH	С	13.28	0.93868			0.00000	"	"			42.8	*	22.7		3778
		4	IН	С	13.35	0.93834		*	0.00000	"	"			42.8	*	22.7		3821
	5	1	Ш	Е	13.28	0.93868	1.85	01.04.22	0	2.33330	-53.62000	44.0	49.0	48.2	191	25.5	1	3869
		2	IН	E	13.35	0.93834		×	0.00000	"	"		u	48.2	*	25.5		3918

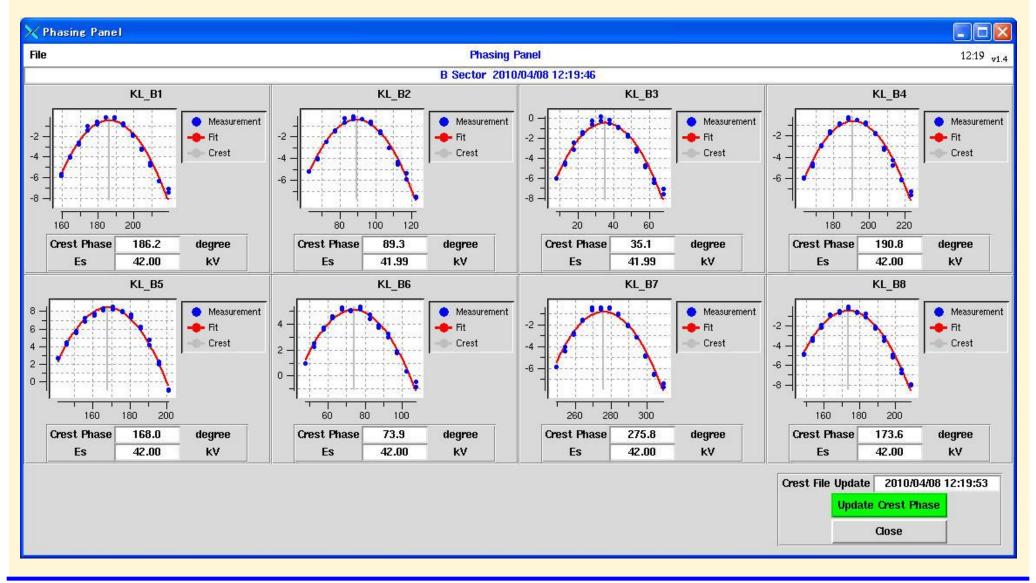


Crest Phase Calibration

- Each power source with slow phase shifter
 - Energy measurement scanning the phase shifter
 - **Primitive but reliable, while there were several methods**
 - Chicken and egg issue exists on bootstrap
 - If no beam at the end, no measurement possible
 - Every several month at least after the long shutdown
 - □ Automated measurement takes ~2hours for 60 sources
 - Result is saved as a reference to other software If the voltage was changed, nominal crest change is applied (1kV => ~8degree) (to be measured later)

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Typical Automated Phase Calibration





Energy Profile

- **♦**8 driver klystrons with fast phase shifters
 - Each manage ~8 high power klystrons
 - Define the overall energy profile
 - With Small phase angle (from the crest)
 - Energy spread compensation depending on beam charge
- 4 klystrons with fast phase shifters
 - Forming two energy-knobs to adjust the energies
 - Before the arc and at the end of the linac
 - Not to enlarge the energy spread
 - **Two klystrons are grouped**

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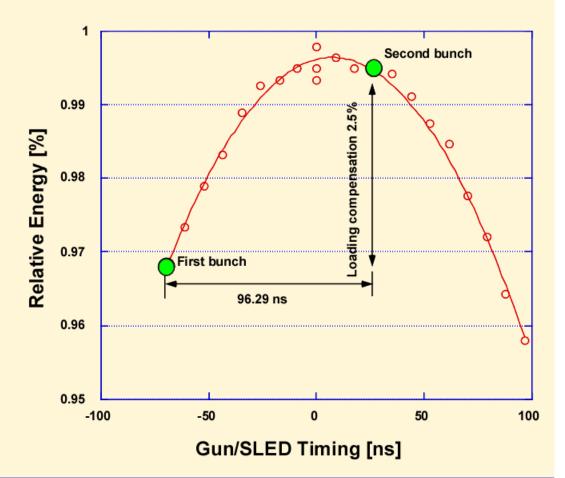


Two-bunch Energy Equalization

- Two bunch in a pulse
 - Energy compensation
 - Depending on beam charge

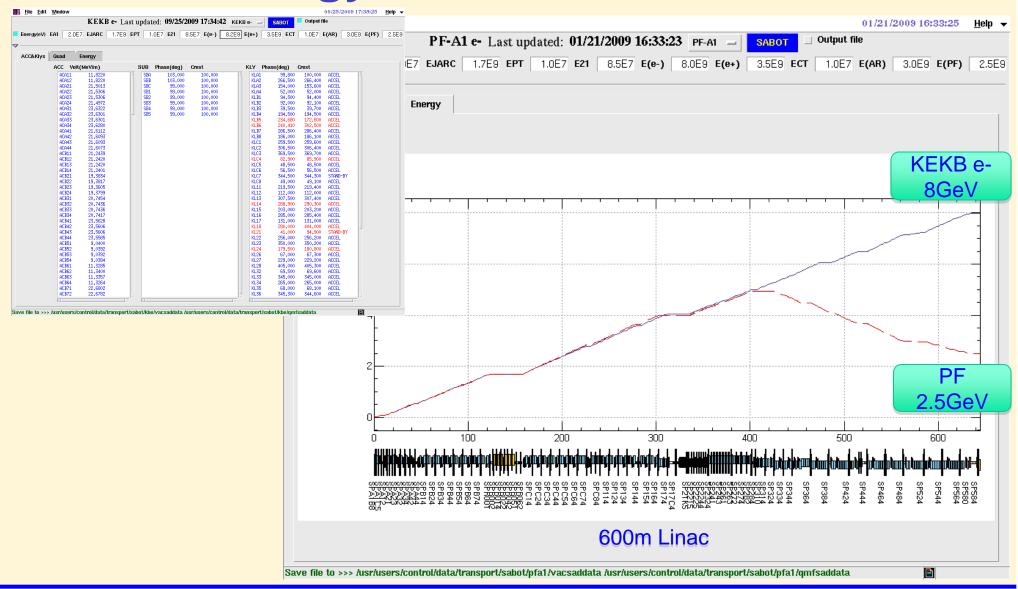
Fast timing adjustment

- Automated measurement
- Same procedure
 - As crest phase measurement
 - **With ns timing as a variable**



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Energy Profile Calculation

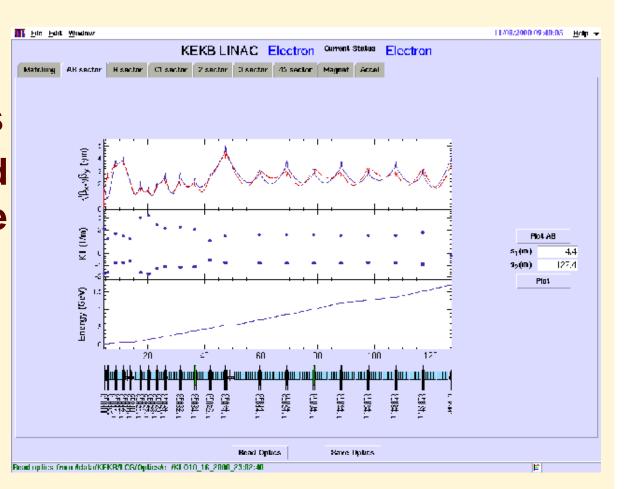




Beam Optics Matching

Based on energy profile, fudge factors, etc.

Wire scanner measurements
Every several days
Somewhat affected by background noise
Matching by a push button



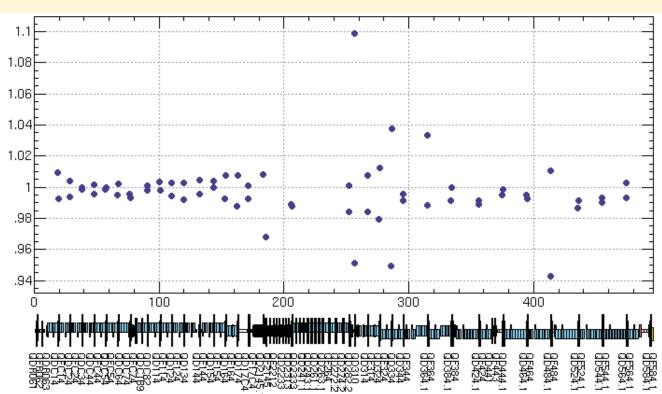


Quad Fudge Factor

Twiss parameter measurement with wire scanners

Fudge factor determination, last done in 2008

 Orbit Observation with Single kicks
 Several iterations
 One wiring error was found





Fast Controls for Three Energy Profiles

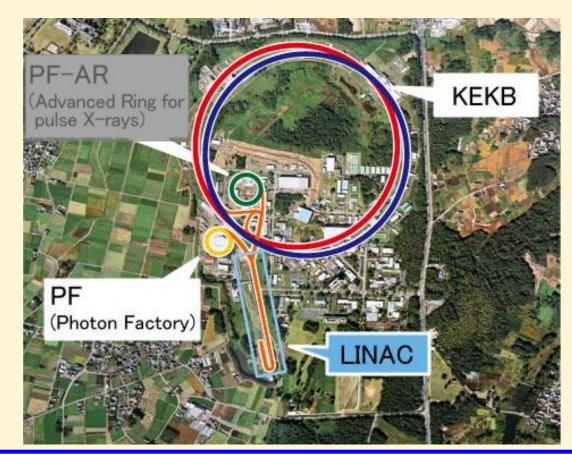
- **♦**8 driver klystrons with fast phase shifters
 - for overall energy profile and energy spread comp.
- Acceleration/stand-by for 60 klystrons
 - \$ for rough energy adjustment, for back-up
- 4 energy knob klystrons
 - \$ for final energy adjustment
- SLED timing of LLRF at 8 driver klystrons
 for two-bunch in a pulse energy equalization

Parameter change every 20ms is necessary



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Simultaneous Injection and Fast Controls





Fast Controls

~100 parameter switching within 20ms
 *Keep most of magnet fields with compatible optics
 *Control IIrf to change energy

Pulsed magnet triggers and delays
Delays to keep the constant rate for certain power-supplies
LLRF phases and delays
Gun voltage and fine delay
Interface to bucket selection, etc

Ethernet-based controls are not reliable enough
 FPGA and fiber-optic RocketIO might be the way ?

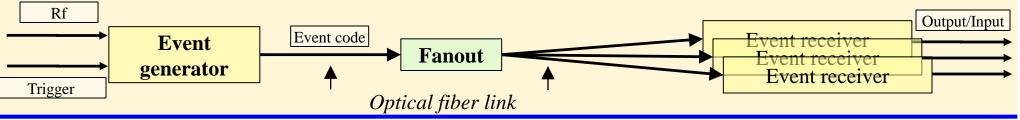


Event System

Many accelerator system require timing signals and accompanying information (event)

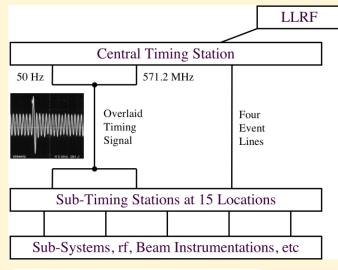
Several primitive facilities are combined and used at KEKB and Linac

- Fast Timing signals are provided with delay module TD4/TD4V
- Need timing trigger and rf clock
- (Slow) Events are provided in another facility
 - Combining Hardware and Software
- Event/Timing Systems which distribute the both timing and event are developed at Argonne/SLS/Diamond, and are employed at many institutes (Event Generator/Receiver)
 - Fast Timing, rf clock, Hardware event, Software Interrupt, can be handled in one combined system with a single fiber cable
 - Especially in EPICS, event can be connected EPICS Event directly, so record/database programming is possible

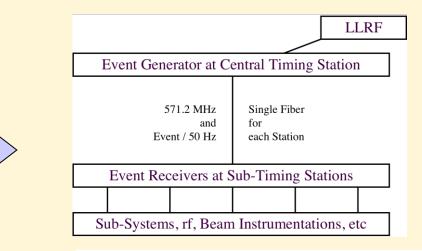


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Timing System



Old Timing Station



New Event Receiver Station with 16 outputs





Event System

Simultaneous Injection
 *to KEKB-HER, KEKB-LER, and PF
 *2.5GeV to 8GeV, 0.1nC to 10nC
 Stable stored beam current at the

Stable stored beam current at three rings

- Should improve collision tuning with Crab cavities
- Should improve the quality of experimental data at PF

Fast switching of many device parameters

- **♦ In 20ms / 50Hz**
- Should be reliable because beam power is much different

MRF Series 230 Event Generator / Receiver

- VxWorks 5.5.1, MVME5500 (Originally with RTEMS but...)
- Timing precision less than 10ps is sufficient (TD4 provides 3ps)
- Multi-mode fiber, and single-mode fiber for longer distance





Event System Configuration



Event Generator

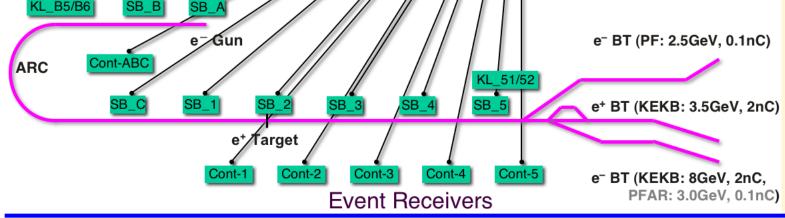
- VME64x and VxWorks v5.5.1
- EPICS R3.14.9 with DevSup v2.4.1
- 17 event receivers up to now

Central



More than hundred 50Hz-Analog/Timing data

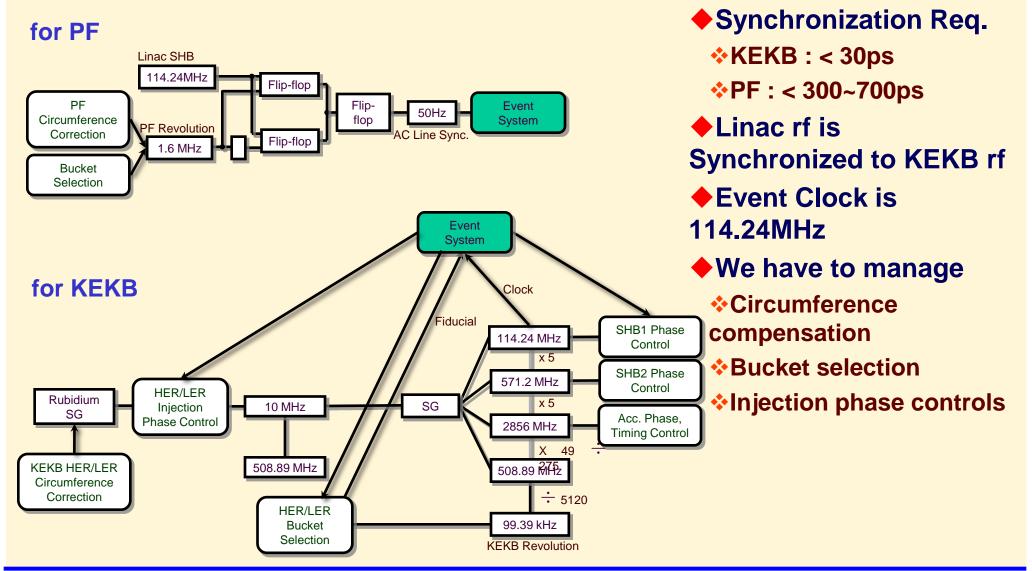




Simultaneous Injection and Energy Management



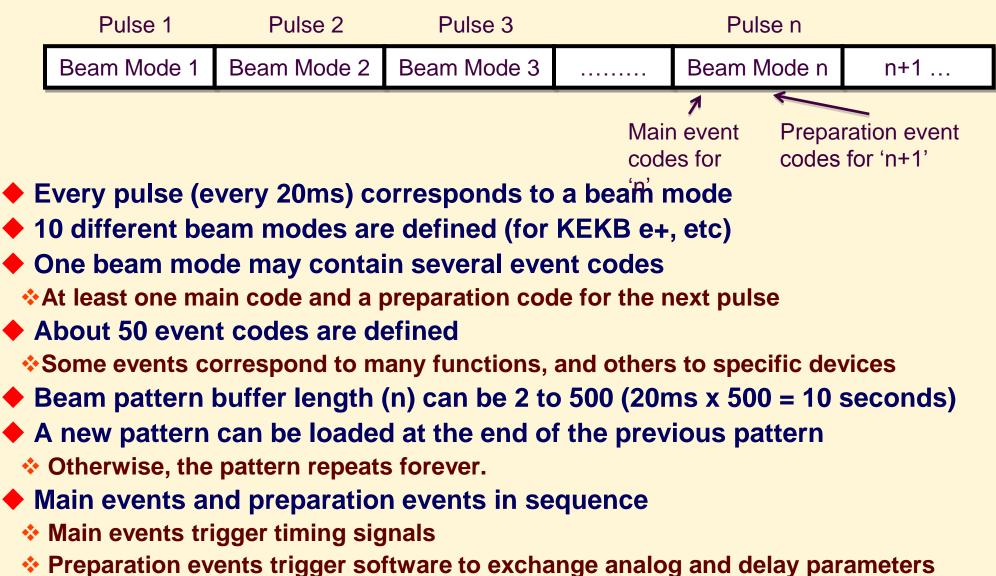
Synchronization Scheme







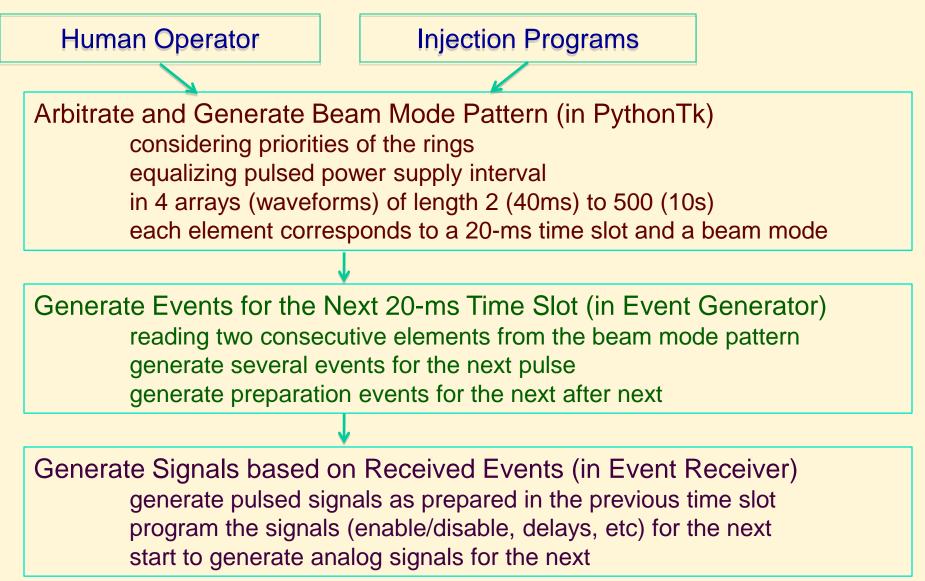
Beam Mode Pattern Generation







Event Manipulation





Beam Mode Pattern Generators

Pattern panel arbitrates requests

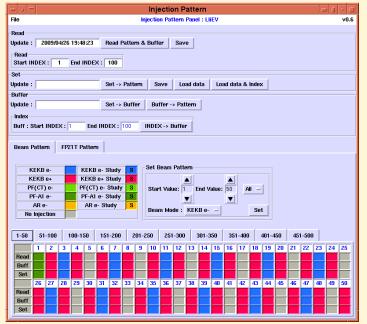
- From downstream rings with priorities, or human operators
- There are several pattern rules due to pulse device features and limitations

Pattern arbitrator software was written in scripting languages to meet daily changes during the commissioning stage

Remote controlled automatic pattern arbitrator

InjPattern-multi										
File		InjPattern-		v0.4						
Priority	👅 base 50Hz 💷 b	ase 25Hz	Update: 2009/04/28 10:51:43							
PF-A1 e-	KEKB e-	KEKB e+	PF(CT) e-	PF-A1 e-	AR e-					
KEKB e+ KEKB e-	25 Hz 💻	0.000 Hz 😑	0.000 Hz 😑	0.5 Hz 😑	0.000 Hz 🛁					
AR e- PF(CT) e-	Set	Set	Set	Set	Set					
KEKB e- Study	12.500 Hz	25.000 Hz	0.000 Hz	0.500 Hz	0.000 Hz					
KEKB e+ Study	12.500 Hz	25.000 Hz	0.000 Hz	0.500 Hz	0.000 Hz					
PF(CT) e- Study	KEKB e- Study	KEKB e+ Study	PF(CT) e- Study	PF-A1 e- Study	AR e- Study					
PF-A1 e- Study AR e- Study	0.000 Hz 🛁	0.000 Hz 🛁	0.000 Hz 🛁	0.000 Hz 🛁	0.000 Hz 🛁					
· ·	Set	Set	Set	Set	Set					
1 J.X	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz					
Up Down	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz	0.000 Hz					
	Read ALL Se	t ALL "O Hz"			Set ALL					
Ready.										

Manual pattern generator





Parameters

Parameters switching via Event system

- ***LLRF phase/timing : 14x4**
- ♦ HP RF timing : ~60
- Gun voltages, picosecond delay : 4
- Pulsed magnets/solenoid : 14
- *Injection phase : 2
- Bucket selection : 2
- **♦BPM** : ~100x3
- Basically sufficient for fast beam mode switching
- More parameters comming
- Integrity monitors

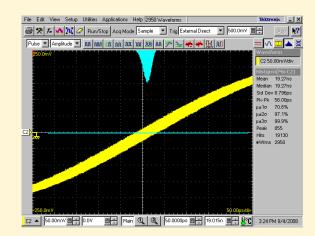
Improved slow beam feedback, fast feedback, etc.

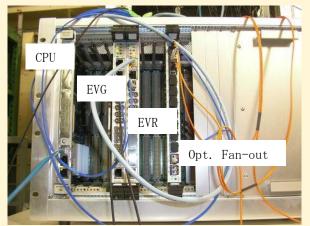


Linac Event System

Satisfies the requirements
Event rate : 114.24MHz (bit rate : ~2.3GHz)
Fiducial rate : 50Hz
Timing jitter (Short term) : ~8ps
No. of defined events : ~50
No. of receiver stations : 17
No. of Fast parameters : ~130

CPU stopped 4 times since Sep.2008 for 18 stations







0.0

Vacuum : 2.1E-8

[A•min]

[Pa]

20 CLOSE

7000.0 [A•h]

BL04

BL 08

.12

.16

[***** ℓ]

∫ Idt:

BL03

BL 07

BL15

[hours]



Beam Current

Time:

BL 05

BI 09

BL13

BI 17

Lifetime :

BL01 CLOSE

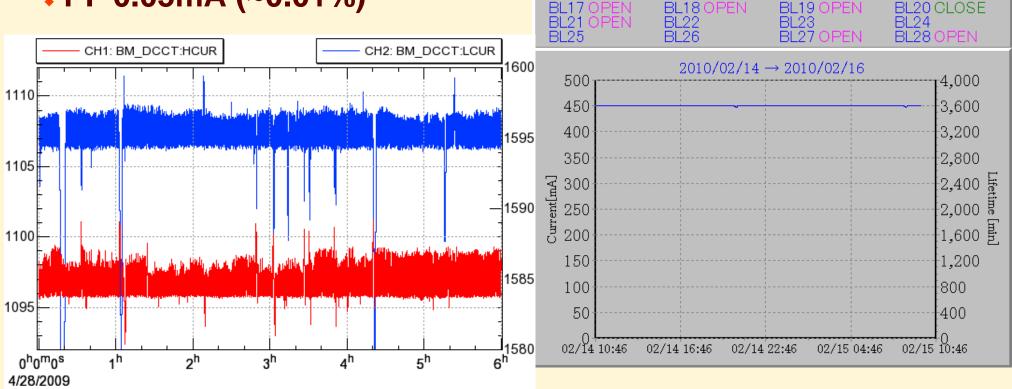
Beam Current: 449.9 [mA]

0.0

BL02

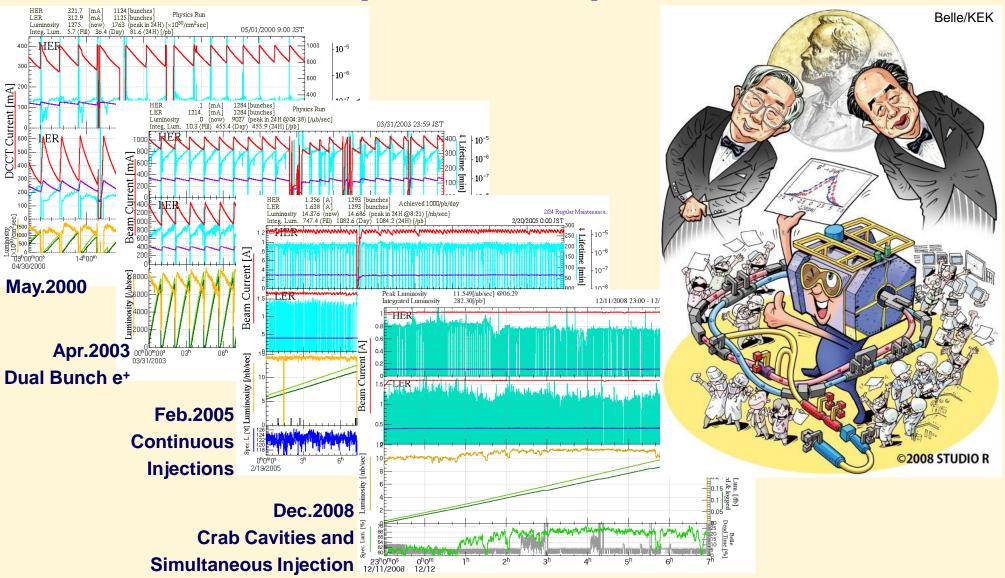
BL 06

Beam currents are kept within ***KEKB 1mA (~0.05%)** PF 0.05mA (~0.01%)



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KEKB Operation Improvement





Summary

Energy management of KEKB linac was successfully applied to simultaneous injection

Covers 2.5GeV – 8GeV, 0.1nC – 10nC

Beam optics diagnosis down to ~1%

Simultaneous injection to HER/LER/PF was successful

Development and installation for various kind of hardware

Another layer of controls based on a fast event system

Pulse-to-pulse reprogramming of event system

Simultaneous injection will be the base for SuperKEKB as well



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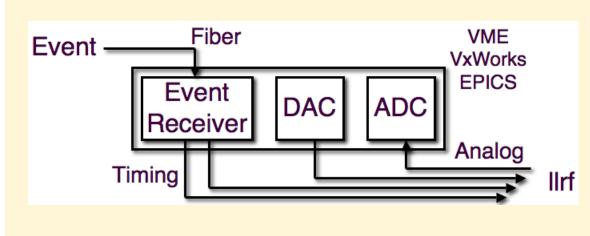
Thank you



LLRF

LLRF Timing/analog signals are essential for absolute energy, energy spread, and dual-bunch energy equalization

- Signals are switched pulse-by-pulse
- Value changes are triggered by a preparation event
- Driver klystrons (SB), energy tuner klystron (KL), and sub-harmonic bunchers (SH) are managed by the event system



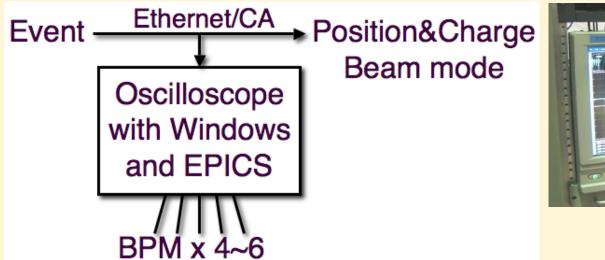


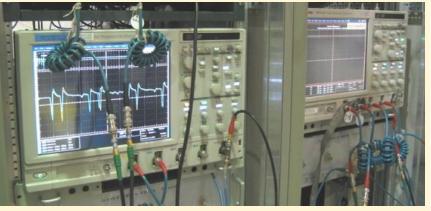




BPM

- Tektronix DPO7104 can acquire data at >50Hz.
 With embedded EPICS
- Beam modes are recognized by events through CA network.
- Clients can monitor data of an interested beam mode.
- 26 oscilloscopes are installed.
- 100 BPMs are synchronized. (100 BPMs at BT as well soon)





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Measurement and Data Acquisition

Originally much efforts to develop detectors, shaping amplifiers

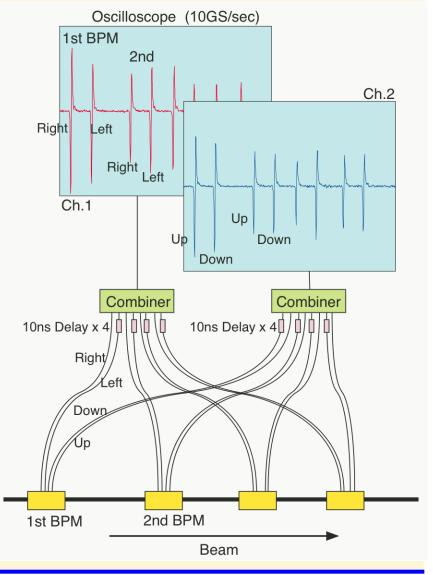
No budget for all BPMs

Switched to direct waveform acquisition

Minimized active components, then minimized calibration tasks, maintenance

Equal-length cables

- One oscilloscope covers about 5 BPMs, or combined 20 (or 40) waveforms
- 5 10Gs/s (with additional interpolation)
- Possible to measure dual bunches
- Solved many issues at once!
- Extract each signal, apply calibration factors, send to upper layer at 50Hz





Embedded IOC on Oscilloscope

DP07104, 10Gs/s, 4ch, 8bit

- Windows-XP
- Cygwin software development environment
- Microsoft Visual C++ 2008
 - x http://www-linac.kek.jp/cont/epics/win32/
- ***EPICS 3.14.8.2**
- Fast data-acquisition at ~150Hz was tricky, but was possible
- Event triggers the data acquisition
- Beam positions and charges are calculated based on ~30 coefficients, and tagged with beam modes
- ♦ 50Hz processing is stable at Linac
- Very efficient for us

KEKB Injections during Beam Studies at PF and PF/AR

